# **Organization of Course**

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# **DIOXIN CASE STUDY**

Prepared in Conjunction with the

#### **Commission for Environmental Cooperation's**

#### **Continental Pollutant Pathways Project**

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Case Study

### Dioxin

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#### 210 Different Congeners, 17 are "toxic"

#### 2,3,7,8-TCDD is believe to be the most toxic



Table 1. Toxic Equivalency Factors (TEF's) for PCDD/F Congeners(U.S.EPA 1994a,b)				
Dibenzo- <i>p</i> -dioxins		Dibenzofurans		
Congener(s)	TEF	Congener(s)	TEF	
dibenzo- <i>p</i> -dioxin molecules with three or less chorine atoms (27 total)	0	dibenzofuran molecules with three or less chlorine atoms (59 total)	0	
2,3,7,8-TCDD	1	2,3,7,8-TCDF	0.1	
all other TCDD's (21 total)	0	all other TCDF's (37 total)	0	
1,2,3,7,8-PeCDD	0.5	2,3,4,7,8-PeCDF 1,2,3,7,8-PeCDF	0.5 0.05	
all other PeCDD's (13 total)	0	all other PeCDF's (26 total)	0	
1,2,3,4,7,8-HxCDD 1,2,3,6,7,8-HxCDD 1,2,3,7,8,9-HxCDD	0.1 0.1 0.1	1,2,3,4,7,8-HxCDF 1,2,3,6,7,8-HxCDF 1,2,3,7,8,9-HxCDF 2,3,4,6,7,8-HxCDF	0.01 0.01 0.01 0.01	
all other HxCDD's (7 total)	0	all other HxCDF's (12 total)	0	
1,2,3,4,6,7,8-HpCDD	0.01	1,2,3,4,6,7,8-HpCDF 1,2,3,4,7,8,9-HpCDF	0.01 0.01	
all other HpCDD's (1 total)	0	all other HpCDF's (2 total)	0	
OCDD	0.001	OCDF	0.001	
Abbreviations:TCDD = Tetrachlorodibenzo-p-dioxinPeCDD = Pentachlorodibenzo-p-dioxinU CDD = U		Abbreviations: TCDF = Tetrachlorodibenzofuran PeCDF = Pentachlorodibenzofuran		
HpCDD = Heptachlorodibenzo- <i>p</i> -di OCDD = Octachlorodibenzo- <i>p</i> -di	oxin xin	HpCDF = Heptachlorodibenzofuran OCDF = Octachlorodibenzofuran		



Human exposure to dioxin is largely through food consumption, rather than from inhalation



Summary of Atmospheric Deposition and Destruction Phenomenon Relevant to PCDD/PCDFs				
	Gas-Phase PCDD/PCDF a significant fraction of the tetra- and penta- chloro PCDD/PCDFs exist in the vapor phase	Particle-Phase PCDD/PCDF essentially all of the hexa-, hepta- and octa-chloro PCDD/PCDFs exist in the particle phase		
Wet Deposition	Depends on solubility of pollutant in water but, PCDD/PCDFs are not very soluble Thus, this is not a very important deposition pathway	In-Cloud: Rainout very efficient deposition mechanism Below-Cloud: Particle Scavenging by falling raindrops less efficient deposition mechanism Lagrangian time scale for air parcel encountering a rain event ~ 1 week		

Summary of Atmospheric Deposition and Destruction Phenomenon Relevant to PCDD/PCDFs				
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	a significant fraction of the tetra- and penta- chloro PCDD/PCDFs exist in the vapor phase	essentially all of the hexa-, hepta- and octa-chloro PCDD/PCDFs exist in the particle phase		
Dry Deposition	Depends on physical chemical properties of pollutant:	Primarily depends on particle size:		
	e.g., adsorption to soil, adsorption to vegetation, solubility in water, etc	Small particles have a lot of surface area, but they have a low deposition velocity		
	Depends on local meteorological conditions:	Big particles have appreciable deposition velocity because of gravity, but, they don't have much surface area		
	e.g., wind speed, turbulence, and temperature	Somewhat dependent on local meteorological conditions:		
	And depends on nature of land surface:	e.g., wind speed and temperature		
	e.g., urban, agricultural, forest, desert, water	Not very dependent on nature of land surface		
Atmospheric Transformation	gas-phase PCDD/PCDF somewhat vulnerable to hydoxyl radical reaction;	particle-phase PCDD/PCDF appear to be much less vulnerable to photolytic or chemical destruction		
	gas-phase PCDD/PCDF less vulnerable to photolysis (but, the rate of this process is relatively uncertain)			

## In 1993, we obtained the HYSPLIT model (version 3)

#### Several modifications made to simulate PCDD/F & Hexachlorobenzene

- Deposition accounting for specific point and area receptors
- Vapor/particle partitioning for semivolatile compounds
- □ Atmospheric chemistry reaction with OH and photolysis
- Particle size distribution for particle-associated material
- □ Particle deposition estimated for each particle size
- Enhanced treatment of wet and dry deposition
- Accounting for five different deposition pathways
  - Dry -- gas
  - Dry -- particle
  - Wet -- below cloud high RH (droplets present below cloud)
  - Wet -- below cloud low RH (dry particles present below cloud)
  - Wet -- in cloud



Deposition from a given puff is assigned to a receptor, based on the overlap with that receptor, for each time step

3

2

12

Image © 2009 GeoEye © 2009 Google Image © 2009 DigitalGlobe © 2009 Cnes/Spot Image at 20.217921° Ion -103.070406° elev 1518 m

4

5

8

Eye alt 89.96 km

**Google** 

# C:\hysplit4\receptors\recp\_data.txt

	minimum longitude of rectangle	maximum longitude of rectangle	minimum latitude of rectangle	maximum latitude of rectangle	
'Lake_Chapala`, 1,	-103.418,	<mark>-103.343</mark> ,	, 20.223	20.289	/
'Lake_Chapala`, 2,	-103.343,	<mark>-103.194</mark> ,	,20.211,	20.288	/
'Lake_Chapala`, 3,	-103.194,	<mark>-103.085</mark> ,	,20.163,	20.285	/
'Lake_Chapala`, 4,	-103.085,	<mark>-102.974</mark> ,	,20.177,	20.331	/
'Lake_Chapala`, 5,	-102.974,	<mark>-102.766</mark> ,	,20.173,	20.311	/
'Lake_Chapala`, 6,	-102.766,	<mark>-102.714</mark> ,	,20.233,	20.290	/
'Lake_Chapala`, 7,	-102.766,	<mark>-102.693</mark> ,	,20.173,	20.211	/
'Lake_Chapala`, 8,	-102.861,	<mark>–102.759</mark> ,	,20.140,	20.174	/
'Lake_Chapala`, 9,	-102.844,	<mark>-102.803</mark> ,	,20.111,	20.140	/
'Lake_Chapala`,10,	-103.156,	<mark>–103.085</mark> ,	,20.285,	20.324	/
'Lake_Chapala`,11,	-103.256,	<mark>-103.194</mark> ,	,20.180,	20.211	/
'Lake_Chapala`,12,	-103.319,	_ <mark>-103.256</mark> ,	,20.199,	20.211	/

# You can add your own receptors!

Also, in addition to "area" receptors, like a lake, point receptors can be added, e.g., corresponding to measurement site locations

This is particularly useful for model evaluation



Fraction of emissions of four dioxin congeners accounted for in different fate pathways anywhere in the modeling domain for a hypothetical 1996 year-long continuous source near the center of the domain.



Deposition amount and flux of 2,3,7,8-TCDD in successive, concentric, annular 200-km-radius-increment regions away from a hypothetical 1996 year-long continuous source near the center of the modeling domain [40° N, 95° W).

# Rate of destruction of PCDD/F congeners by photolysis is particularly uncertain....

To help understand uncertainties, sensitivity analyses can be very useful







# Dry Deposition and Surface Exchange

Process Information: 1. Dry Deposition - Resistance Formulation

$$V_{d} = ----- + V_{g}$$
$$R_{a} + R_{b} + R_{c} + R_{a}R_{b}V_{g}$$

in which

- R<sub>a</sub> = aerodynamic resistance to mass transfer;
- $R_b = resistance$  of the quasi-laminar sublayer;
- R<sub>c</sub> = overall resistance of the canopy/surface (zero for particles)
- $V_g$  = the gravitational settling velocity (zero for gases).

# Dry Deposition

- depends intimately on vapor/particle partitioning and particle size distribution information
- $\Box$  resistance formulation [R<sub>a</sub>, R<sub>b</sub>, R<sub>c</sub>...]
- $\Box$  for gases, key uncertainty often R<sub>c</sub> (e.g., "reactivity factor" f<sub>0</sub>)
- $\Box$  for particles, key uncertainty often R<sub>b</sub>
- □ How to evaluate algorithms when phenomena hard to measure?

# **Particle dry deposition phenomena**

**Atmosphere above the quasi-laminar sublayer** 



Surface

Ra



Table 3. Alternative Dry Deposition MethodologiesUsed in this Modeling Analysis						
		Water Surfaces		Land or Vegetative Surfaces		
Dry Deposition		Particles	Vapor	Particles	Vapor	
	Method	(if no entry	in table, then use oj	f default methodology	is implied)	
А	default					
<b>A</b> ′	default with no RH correction	no correction for hygroscopic growth of particle near water surface				
В	modified HYSPLIT_3 resistance methodology	Same as A for land/vegetative surfaces, except that exponent on $Sc$ in $R_b$ formulation is -0.5, instead of - 0.67				
С	ADOM-II for particles	same as B, with addition of 0.01 cm/sec phoretic velocity component	same as B	different functional dependence on <i>St</i> in $R_b$ formulation; addition of 0.01 cm/sec phoretic velocity component; exponent on <i>Sc</i> : - 0.5 for z0 < 10cm, and -0.7 for z0 > 10 cm		
D	Williams (1982) for particles depositing to water	Williams (1982)	same as B			
E	HYSPLIT_4 resistance methodology	similar to B, except that R <sub>b</sub> set to 10 sec/m (a relatively low value)	same as B	a different functional dependence on <i>St</i> in R <sub>b</sub> formulation	essentially the same as A	

Figure 5. Variations in simulated 1996 deposition of 2,3,7,8-TCDD and OCDD to Lake Michigan with alternative dry deposition methodologies. "TCDD" = 2,3,7,8-TCDD; "Milw" indicates source in Milwaukee, WI; "center" indicates source at center of modeling domain; "SF" indicates source in San Francisco, CA.





# More Information on Vapor / Particle Partitioning

In the atmosphere, pollutants can exist, generally, in the vapor phase or associated with particles, i.e., the aerosol phase.

□ For semivolatile compounds there can be there can be significant fractions associated with either phase.

This phenomenon is of crucial importance in determining the fate of semivolatile compounds in the atmosphere, <u>because each of the deposition and</u> <u>destruction mechanisms depend a great deal on the</u> <u>physical form of the pollutant</u>.

The vapor/particle partitioning phenomenon was first introduced by Junge (1977), and has been extended and reviewed by many... The theory of vapor-particle partitioning postulates that for any species in the atmosphere, there is an equilibrium between vapor phase and the particle phase that depends primarily on:

the physical-chemical properties of the species of interest,

□ the nature of the atmospheric aerosol,

□ and the temperature.

As proposed by Junge (1977), the vapor-particle partitioning of <u>exchangeable</u> material can be estimated from the following equation:

$$\Phi = c S_t / (p(T) + cS_t)$$

where

 $\Phi$  = the fraction of the total mass of the species absorbed to the particle phase (dimensionless)

 $S_t$  = the total surface area of particles, per unit volume of air (cm<sup>2</sup>/cm<sup>3</sup>)

p(T) = the saturation vapor pressure of the species of interest (atm), at the ambient temperature (T)

c = an empirical constant, estimated by Junge (1977) to be approximately  $1.7 \times 10^{-4}$  atm-cm

The most thermodynamically stable form of many semivolatile species at ambient temperatures is typically a solid, but, Bidleman (1988) has argued that it is the "non-equilibrium" or subcooled liquid phase which controls the dynamic equilibrium partitioning of such compounds between the vapor phase and the atmospheric aerosol. Thus, the subcooled liquid vapor pressure at the ambient temperature should be used in the above equation.

This vapor pressure can be approximately estimated from the following equation:

 $\ln (P/P_s) = \Delta S_f (T_m - T) / RT$ 

where

 $P_I$  = subcooled liquid vapor pressure (atm) at temp. T  $P_s$  = solid vapor pressure (atm) at temperature T  $\Delta S_f$  = entropy of fusion (atm m<sup>3</sup>/mole deg K) (approximately equal to 6.79 R)  $T_m$  = melting temperature of the solid compound (deg K) T = ambient temperature (deg K) R = the gas constant (atm m<sup>3</sup>/mole deg K) The solid vapor pressure at the temperature of interest can be estimated from the reported solid vapor pressure at a standard temperature with the Clausius-Clapeyron equation using the enthalpy of vaporization, according to the following equation:

 $\ln (P_{1}^{s} / P_{2}^{s}) = (\Delta H / R) (1/T_{2} - 1/T_{1})$ 

where

 $P_1^s$  = solid vapor pressure (atm) at temperature  $T_1$ 

 $P_2^s$  = solid vapor pressure (atm) at temperature  $T_2$ 

 $\Delta H$  = enthalpy of vaporization (J/mole)

Note: according to Trouton's Rule,  $\Delta H$  can be approximately estimated by the following relation:  $\Delta H / T_{boil} = 84$  J/(mol degK) (Mackay et al 1986).

- R = gas constant (J/mole degK [=] (atm m<sup>3</sup>/mole deg K)
- $T_2$  = temperature 1 (deg K)
- $T_1$  = temperature 2 (deg K)

- Thus, the vapor particle partitioning for a given compound in the atmosphere can be estimated from the first of the above two equations, with P<sub>1</sub> from the second equation used for P(T).
- The only species-specific physical-chemical property data required to make a vapor/particle partitioning estimate according to the above simplified approach are the species' <u>solid vapor</u> <u>pressure at one temperature</u>, and the species' <u>boiling and melting temperatures</u>.

 It is typically assumed that semivolatile compounds in the atmosphere are "fully exchangeable", i.e., that the compound can move freely between the vapor and particle phases, depending on the dictates of thermodynamics.

To the extent that a portion of the material is "locked-up" within particles and is not available for exchange, this assumption would be in error.